



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Christopher H. McCoy et al.

Serial No. 10/714,190

Filed: November 14, 2003

For: **SOFT LITHOGRAPHIC PROCESS FOR FABRICATING INTEGRATED ITO  
ELECTRODE-LIQUID CRYSTAL ALIGNMENT LAYERS**

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: Group Art Unit: 2879  
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: Examiner: Joseph Williams

CERTIFICATE UNDER 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being as first class mail in an envelope addressed to  
Mail Stop Issue Fee, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on

4-10-06

Date

Susannah Fernandez  
Susannah Fernandez

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. 1.312**

In response to the Notice of Allowance dated April 6, 2005, please amend the  
typographical errors in the above-identified application as follows:

**Amendments** to the Specification are reflected in the following page, which begins on  
page 2 of this paper.

**Remarks** begin on page 3 of this paper.